

<b>Notice of References Cited</b>	Application/Control No. 10/688,281	Applicant(s)/Patent Under Reexamination YUN ET AL.	
	Examiner A. Dexter Tugbang	Art Unit 3729	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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*	B	US-6,334,244	01-2002	Hashizume, Tsutomu	29/25.35
	C	US-			
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	F	US-			
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	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

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**NON-PATENT DOCUMENTS**

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	U	Kline-Schoder et al., "Physical Vapor Deposition of Multilayer Lead-Zirconate-Titanate Films for Ultrasonic Transducer Fabrication", 1997 IEEE Ultrasonics Symposium, Volume 2, October 1997, pages 937-942.
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\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.